

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANT(S): Koji Naniwada

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GROUP ART UNIT: 2817

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EXAMINER: Unknown

INVENTION: MEMS TYPE RESONATOR, PROCESS FOR FABRICATING THE SAME
AND COMMUNICATION UNIT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

SIR:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the reference identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. This reference was cited in a search report issued on May 18, 2007, in connection with EPO counterpart application No. EP 04 74 7996. A copy of the European Search Report is attached.

Respectfully submitted by,

/David R. Metzger/ (Reg. 32,919)

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